

FORM PTO-1449	U.S. DEPARTMENT OF COMMERCE	ATTY. DOCKET NO. H1508	SERIAL NO Not yet assigned 18/697,214
PATENT AND TRADEMARK OFFICE		APPLICANT Christine Hau-Riege, et al.	
INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use several sheets if necessary)		FILING DATE Herewith 29 OCT 03	GROUP 2823

U.S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
Q/B	6,245,996	06/12/01	Atakov, et al.	174	68.1	2
Q/B	2001/0001427	05/24/01	Atakov, et al.	174	113 R	2

FOREIGN PATENT DOCUMENTS

DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION
					YES NO

OTHER DOCUMENTS (Including Author, Title, Date Pertinent Pages, Etc.)

Q/B	X	Ogawa, E.T., et al., Stress-Induced Voiding Under Vias Connected To Wide Cu Metal Leads,

EXAMINER

William M. Brewster

DATE 9 DEC 03
CONSIDERED

EXAMINER: Initial citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.